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Docket No.: M4065.0706/P706  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Jiutao Li et al.

Application No.: 10/712,106

Confirmation No.: 8216

Filed: November 14, 2003

Art Unit: 1753

For: SILVER SELENIDE SPUTTERED FILMS  
AND METHOD AND APPARATUS FOR  
CONTROLLING DEFECT FORMATION  
IN SILVER SELENIDE SPUTTERED  
FILMS

Examiner: Not Yet Assigned

**SECOND STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorneys named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: July 12, 2005

Respectfully submitted,

By 

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